



Designation: D2029 – 97 (Reapproved 2017)

Standard Test Methods for Water Vapor Content of Electrical Insulating Gases by Measurement of Dew Point¹

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This standard has been approved for use by agencies of the U.S. Department of Defense.

1. Scope

1.1 These test methods describe the determination of the water vapor content of electrical insulating gases by direct or indirect measurement of the dew point and the calculation of the water vapor content.

1.2 The following four test methods are provided:

1.2.1 *Method A* describes the automatic chilled mirror method for measurement of dew point as low as -73°C (-99°F).

1.2.2 *Method B* describes the manual chilled mirror or dew cup method for measurement of dew point as low as -73°C (-99°F).

1.2.3 *Method C* describes the adiabatic expansion method for measurement of dew point as low as -62°C (-80°F).

1.2.4 *Method D* describes the capacitance method for measurement of dew point as low as -110°C (-166°F).

1.3 *This standard does not purport to address all of the safety concerns, if any, associated with its use. It is the responsibility of the user of this standard to establish appropriate safety and health practices and determine the applicability of regulatory limitations prior to use.* For specific warnings, see [8.1.1](#), [9.2](#), [10.1.2](#) and [10.2.5](#).

2. Referenced Documents

2.1 *ASTM Standards*:²

[D1933](#) Specification for Nitrogen Gas as an Electrical Insulating Material

[D2472](#) Specification for Sulfur Hexafluoride

[D3283](#) Specification for Air as an Electrical Insulating Material

¹ These test methods are under the jurisdiction of ASTM Committee D27 on Electrical Insulating Liquids and Gases and are the direct responsibility of Subcommittee D27.07 on Physical Test.

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² For referenced ASTM standards, visit the ASTM website, www.astm.org, or contact ASTM Customer Service at service@astm.org. For Annual Book of ASTM Standards volume information, refer to the standard's Document Summary page on the ASTM website.

3. Terminology

3.1 *Definitions*:

3.1.1 *dew point, n*—the temperature to which a gas must be cooled at constant pressure and constant water vapor content in order for saturation to occur. Any further cooling usually results in formation of the first drop of dew.

3.1.2 *hygroscopic, adj*—readily taking up and retaining moisture.

4. Summary of Test Methods

4.1 *Method A*—The automatic chilled mirror method uses the chilled mirror dew point condensation principle to determine the water vapor content in gas mixtures. An internal mirror, which is in the path of the test gas, is automatically cooled. Internal electronics sense the presence of moisture on the mirror. The device then automatically brings itself to equilibrium and provides a direct reading of dew point temperature.

4.2 *Method B*—This method uses the same basic condensation principle in [4.1](#); however, the manual chilled mirror method uses a mixture of acetone and ice or other cooling media to manually chill the dew cup polished surface which acts as the mirror.

4.3 *Method C*—Adiabatic expansion uses a process in which the test gas is cooled rapidly to determine dew point temperature. This rapid exhausting of the test gas to atmosphere results in an expansion and cooling of the gas. If the cooling is sufficient to reduce the temperature of the gas to or below the dew point, water vapor will condense out in the form of a fine mist or fog. Successive trials will determine the minimum initial pressure that will produce a fog. From this, the dew point temperature can be calculated.

4.3.1 The relationship between pressure and temperature during adiabatic expansion is as follows:

$$T_F = T_I [P_F / P_I]^{(K-1/K)}$$

where:

K = ratio of specific heats for a given gas,
 T_F = final temperature,
 T_I = initial temperature,

P_F = final pressure, and
 P_I = initial pressure.

4.4 *Method D*—The capacitance method uses a moisture sensor, typically aluminum oxide or silicon oxide, which changes its electrical output with the amount of water vapor to which it is exposed.

5. Significance and Use

5.1 Certain gases have excellent dielectric and electric arc interruption characteristics which make their use in electrical installations very desirable.

5.2 Water content, as the test parameter, is of great importance in determining the dielectric effectiveness of the gas. Under certain conditions, water may condense and become a conducting liquid resulting in a catastrophic dielectric breakdown of the insulation. The water content of these insulating gases as expressed by dew point is listed in Specifications [D1933](#), [D2472](#), and [D3283](#).

5.3 Once the dew point is determined, a conversion to moisture content may be performed using [Table 1](#). Once moisture content is known, the lowest temperature at which gas insulated equipment can be safely operated can usually be determined by reviewing manufacturers' specifications for the equipment.

5.4 The dew point of the test gas is independent of the gas temperature but does depend on its pressure. Many moisture measurement test instruments are sensitive to pressure, and display moisture values at the instrument inlet pressure and not necessarily at the pressure of the system being sampled. It is therefore important to account for this condition to avoid serious measurement errors.

6. Interferences

6.1 Tubing:

6.1.1 Most new metal tubing contains oil deposits on the interior walls due to the manufacturing process. This residue should be removed before using these lines for gas sampling.

6.1.2 Tubing should be free of leaks, since even a pinhole leak will result in a false indication (higher dew point), due to the partial pressure of water vapor in the atmosphere.

6.1.3 When the gas being tested is extremely dry [dew point below approximately -40°C (-40°F)], results can be misleading until the moisture adsorbed in the system (tubing, regulators, etc.) has been removed by purging with the test gas. At this point, all moisture present within the system should be due to that contained in the test gas.

6.2 When testing gases that contain readily liquefiable impurities, it must be kept in mind that the dew point that is measured by condensation type instruments may be due to these impurities rather than to water. Under these conditions, the measured dew point is not an indication of the water content of the gas.

6.3 Measurement of water vapor in very dry gases is complicated by four considerations, as follows:

6.3.1 For Methods A, B, and C, the relatively large volume of gas required to deposit sufficient water vapor to create the "dew".

6.3.2 For Methods A, B, and C, that under very dry condition, the possibility exists to condense the test gas prior to deposition of moisture on the mirror.

6.3.3 For Methods A, B, C, and D, that the measuring system (instrument and tubing) must not entrain moisture. If any moisture is entrained, several hours may be required for the gas being measured to come into equilibrium with the measuring system.

6.3.4 For Methods B and C, the sensitivity of the human eye in determining exactly when the dew first forms.

7. General Requirements

7.1 *Methods A, B, and C*—Any properly constructed dew point apparatus may be used that provides a means to satisfy the following basic requirements:

7.1.1 Control the flow of gas entering and leaving the apparatus while the apparatus is at a temperature at least 2°C (3.6°F) above the dew point of the gas.

7.1.2 Control the cooling rate of a chamber in the apparatus through which the flowing gas passes to a temperature low enough to cause water vapor to condense from the gas.

7.1.3 Detect the deposition of dew on the cold portion of the apparatus and measure the temperature at which dew is formed.

7.1.4 Ensure that the test gas is at or near atmospheric pressure and is isolated from contamination from other gases.

7.2 *Method D*—Any properly constructed capacitive type moisture sensor may be used that provides a means to satisfy the following basic requirements:

7.2.1 Expose the sensor to a gas that is at a temperature at least 10°C (18°F) above the dew point of the gas.

7.2.2 Measure the partial vapor pressure of water in a gas by means of a capacitive type sensor.

7.3 These test methods provide for several techniques, each utilizing different types of apparatus for measuring dew point. The techniques in these test methods are provided for general information and are not intended as a substitute for manufacturer's instructions. When using any instrument, the manufacturer's instructions should be followed to ensure proper and safe operation.

8. Apparatus

8.1 General:

8.1.1 *Tubing*—Although not true of all applications, stainless steel, glass, and nickel alloy tubing are the best possible nonhygroscopic materials and should be used for low dew point applications -18 to -73°C (0 to -100°F). Copper and aluminum alloys, as well as stabilized polypropylene tubing, are acceptable above -29°C (-20°F) dew point. (**Warning**—All materials will adsorb moisture to some extent; therefore, the internal surface of apparatus, tubing, and fittings should be minimized to enable the system to dry out more quickly and achieve equilibrium sooner. However, it should be noted that when one switches from measurement of a high dew point to a lower dew point [that is, 0 to -60°C (32 to -76°F)] copper